

Atomic Layer Deposition for Thin Film Solid-State Batteries

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#	ARTICLE	IF	CITATIONS
1	Atomic Layer Deposition“ A Versatile Toolbox for Designing/Engineering Electrodes for Advanced Supercapacitors. Advanced Science, 2024, 11, .	11.2	6
2	Cost-Effective and EnvironmentallyÂFriendly Mass Manufacturing of Optical Metasurfaces Towards Practical Applications and Commercialization. International Journal of Precision Engineering and Manufacturing - Green Technology, 2024, 11, 685-706.	4.9	1